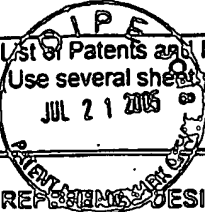


Form PTO-1449 (Modified)		Atty Docket No.: P18237		Serial No.: 10/829,592			
<div style="text-align: center;">  </div> List of Patents and Publications Statement Use several sheets if necessary				Applicant: Michael D. Goodner et al.			
				Filing Date: April 21, 2004			
REFERENCES DESIGNATION			U.S. PATENT DOCUMENTS				
Examiner Initials		Document No.		Class	Sub-Class	Filing date if appropriate	
<i>JA</i>	AA	6,252,290 B1	Quek et al. 06/2001	257	522	X	
<i>JA</i>	AB	6,833,320 B2	Meagley et al. 12/2004	438	640		
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	AE						
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
No.		Document No.	Date	Country	Class	Sub-Class	Translation
<i>JA</i>	AI	102 38 024 A1	3/11/2004	Germany	H01L	21/768	
	AJ						
	AK						
OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)							
<i>JA</i>	AL	Robert P. Meagley et al., "Photodefinable Polymers for Semiconductor Applications", Serial No. 10/337,575, Filed January 6, 2003.					
	AM	Robert P. Meagley et al., "Photodefinable Polymers for Semiconductor Applications", Serial No. 10/616,895, Filed July 10, 2003.					
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	AU	Vijayakumar S. RamachandraRao et al., "Post-Deposition Modification of Interlayer Dielectrics", Serial No. 10/609,963, Filed June 30, 2003.					
<i>JA</i>	AV	Robert P. Meagley, "Photoactive Adhesion Promoter", Serial No. 10/288,021, Filed November 4, 2002.					
	AW						
Examiner <i>[Signature]</i>			Date Considered 12/29/05				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

KS
01/26/07